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## Search History

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Set Name side by side	Query	<u>Hit</u> Count	<u>Set</u> <u>Name</u> result set
DB=PGPB,USPT; PLUR=YES; OP=OR			
<u>L31</u>	118 and 122	28	<u>L31</u>
<u>L30</u>	118 and 121	65	<u>L30</u>
<u>L29</u>	118 and 120	124	<u>L29</u>
<u>L28</u>	118 and 126	218	<u>L28</u>
<u>L27</u>	L26 and l19	34	<u>L27</u>
<u>L26</u>	(712/2-300)[CCLS]	12719	<u>L26</u>
<u>L25</u>	119 and 122	4	<u>L25</u>
<u>L24</u>	119 and 121	11	<u>L24</u>
<u>L23</u>	119 and 120	21	<u>L23</u>
<u>L22</u>	(711/132)[CCLS]	145	<u>L22</u>
<u>L21</u>	(711/120-173)[CCLS]	19825	<u>L21</u>

<u>L20</u>	(712/200-219,225-227, 241-248)![CCLS]	5783	<u>L20</u>
DB=P	GPB, USPT, USOC, EPAB, JPAB, DWPI, TDBD; PLUR=YES; OP=OR		
<u>L19</u>	L18 and (thread\$3 or multi near1 thrread\$3)	90	<u>L19</u>
<u>L18</u>	push\$4 near25 pop\$4 near25 stack near25 point\$3	549	<u>L18</u>
<u>L17</u>	push\$4 near25 pop\$4 near25 stack near25 (sram or static) near25 point\$3	0	<u>L17</u>
DB=U	JSPT; PLUR=YES; OP=OR		
<u>L16</u>	13 and memor\$4	1	<u>L16</u>
<u>L15</u>	L14 and (push or pop) ·	29	<u>L15</u>
<u>L14</u>	stack near5 sram	109	<u>L14</u>
<u>L13</u>	L12 and sram	0	<u>L13</u>
<u>L12</u>	5946487.pn.	1	<u>L12</u>
<u>L11</u>	L10 and sram	0	<u>L11</u>
<u>L10</u>	5968169.pn.	1	<u>L10</u>
<u>L9</u>	L8 and sram	0	<u>L9</u>
<u>L8</u>	3889243.pn.	1	<u>L8</u>
<u>L7</u>	L4 and ram\$1	0	<u>L7</u>
<u>L6</u>	L4 and sram\$1	0	<u>L6</u>
<u>L5</u>	L4 and sram	0	<u>L5</u>
<u>L4</u>	L3 and offset	1	<u>L4</u>
<u>L3</u>	5542070.pn.	1	<u>L3</u>
<u>L2</u>	associat\$3 near8 pop near8 push	54	<u>L2</u>
<u>L1</u>	assosicat\$3 near8 pop near8 push	0	<u>L1</u>

## END OF SEARCH HISTORY



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	· .		AbstractPlus   Full Text: PDF(168 KB) ISEE CNF Rights and Permissions		
			<ol> <li>StackOFFence: a technique for defending against buffer ove Madan, B.B.; Phoha, S.; Trivedi, K.S.; Information Technology: Coding and Computing, 2005, ITCC 200 Volume 1, 4-6 April 2005 Page(s):656 - 661 Vol. 1 Digital Object Identifier 10.1109/ITCC.2005.260</li> </ol>		
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			<ol> <li>Repetitive 600 kV vacuum insulator testing system for insula Stoltzfus, B.S.; Elizondo, J.M.; Savage, M.E.;</li> <li>Plasma Science, 2004, ICOPS 2004, IEEE Conference Record - 28 June-1 July 2004 Page(s):444</li> <li>Digital Object Identifier 10.1109/PLASMA.2004.1340259</li> </ol>		
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			4. Development of an etchant for selectively etching TiWN <sub>x</sub> in the Ramanathan, L.N.; Mitchell, D.; Electronic Components and Technology Conference, 2000, 2000, 21-24 May 2000 Page(s):837 - 843 Digital Object Identifier 10.1109/ECTC.2000.853258		
			AbstractPlus   Full Text: PDF(612 KB) Rights and Permissions		
			<ol> <li>3-D PIC simulations of electron flow in the vacuum power flow Pointon, T.D.;</li> <li>Pulsed Power Plasma Science, 2001. IEEE Conference Record 17-22 June 2001 Page(s):525</li> <li>Digital Object Identifier 10.1109/PPPS.2001.961335</li> </ol>		

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